IBL Project Overview

9th Trento Workshop

Genova, February 26-28, 2014

D. Ferrère on behalf of the ATLAS Pixel community



Overview

- IBL project Introduction and layout & original challenges
- Detector & FE design features
- The module and stave production
- The module loading & stave QA overview
- Summary of issues met
- Overview of the produced staves
- IBL package and engineering work
- The integration & tests
- Feedback from the tests FBK noise features
- The IBL insertion tests & CO₂ cooling system
- Towards completion and timelines
- Conclusions

Introduction and Layout

^{Reduce} beam pipe diameter (47mm)

0.5- nota 1

R31- IBL inner envelope R28.3- beam pipe envelope R24.3- beam pipe outer R23.5- beam pipe inner R42.5- IST inner R43 - IST outer

in Beryllium already integrated

IBL is an additional inner most Pixel layer that will improve our tracking performance

D,

Features:

14°

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Reference poin

- \checkmark 4th Pixel layer (instead of b-layer replacement)
- \checkmark Closer interaction point (5.05 \rightarrow 3.27cm)
- \checkmark Smaller pixels (50 x 250 μ m2)
- ✓ Better sensors, better R/O chip
- ✓ More robust tracking
- ✓ Better performance

Pixel with old beam pipe

Rendering view with IBL and smaller R40 - IBL outer envelope beam pipe R34.92- pipe radius R32.77- module radius

Sensor designs

3D and planar technology are used in combination on the same stave

| Features | Planar | 3D |
|---|-------------|-------------|
| Thickness (nominal) [µm] | 200 | 230 |
| Depletion voltage [V] | ~50 | 10 - 25 |
| Working voltage after LHC fluence (5x10 ¹⁵ 1MeV n _{eq} /cm ²) [V] | ~1000 | ~160 |
| Pixel [FE x Row x Column] | 2x336x80 | 1x336x80 |
| Active size WxL [mm ²] | 16.8 x 40.9 | 16.8 x 20.0 |

Planar features:

- n-in-n technology
- Lower thickness than Pixel
- Inactive edge minimized to 200 microns



3D features:

- **D**ouble-side **D**ouble **T**ype **C**olumns (DDTC) process
- Guard ring fence: 200 microns inactive area
- CNM: No full 3D columns (210 μm)
- **FBK:** Full 3D columns (230 μm)



Front-end readout – FEI4

FEI4 main features:

- IBM (130 nm)
- 70 Million transistors
- 26880 pixels (50 x 250 µm2)
- Lower noise than FE-I3 (~150e- with sensor) -
- Lower threshold operation -
- Higher rate capability
- Radiation hard to >250Mrad
- In use for pixel R&D and towards Upgrade phase2 -

Through the FEI4 history:

- First version FEI4a for validation and IBL prototypes (32 FE-I4A wafers received in 2010/11)
- \blacktriangleright FEI4b features: minor fixes + r/o functionalities + uniform pixel matrix + Power functionality
- First FEI4b delivery in Dec. 2011
- FEI4b production (30 wafers) and wafer probing is completed for IBL needs (yield ~60%)





IBL description:

• 14 staves overlapping in Phi and mounted around the beam pipe on the IPT (Inner Positioning Tube)

Stave Layout

- All the staves and services will be integrated inside 12mm envelope in radius along ~7m long
- Small clearances between beam pipe IPT- staves IST
- Stave to stave gap is only 0.8mm \rightarrow Integration for the last stave delicate
- An instrumented stave (32 FE chips) consists of **12 planar** and **8 3D** sensor modules along 664mm)



Module Production

Thin module process steps:

- FE-I4 wafers thinned (150µm thick FE)
- Glued on glass support wafer
- Bump deposition
- Dicing wafer & substrate
- Flip-chip & reflow

Yield ~75%

Yield ~62%

Substrate wafer removal by power laser.

Final module assembly and QA (at Bonn & Genova)

- Module dressing: DC module with flex
- Wire bonding
- Electrical QA and TC (including debug)

220



200

nemo workshop, Genova 2014

Module Production – Failure along batches





Amount per batch

Bump Bonding (BB) failures were monitored all along the production since this was the major concern during the 1st 3 batches

Module Production – Issues with 1st batches

1st batches started in June 2012

It was observed high failure rate mainly because of two types of defects:

- Open: large fraction of the pixel are not properly connected to the FE pads (seen in the noise map without HV and confirm with the source scan)
- "Shorts": On some region of the FE it was observed coupling between surrounding pixels like shorted pixels or merge bumps (seen on the crosstalk scan)
- ightarrow Stopped production in September 2012
- \rightarrow Investigations made:
 - Open bumps traced back to be excessive flux in Flip Chip process.
 - Still lack a convincing explanation of the origin of shorts but problem got vanished with flux-free flip chip.
- → Restarted production with flux free Flip Chip after PRR in February 2013
- → The original issue was not observed in later batches (from batch 4ff)



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Stave Flex overview

Stave production and features:

Production is complet

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- Production was done at Wuppertal IVW
- Stave QA and preparation on handling frame followed at CPPM
- Ti pipe of 1.5mm ID and 0.1mm wall thickness
- Face plate (module side) is coated with Parylen for safer electrical break to detector HV
- Tight planarity and envelope tolerance: +/- 0.15mm
- Stave fixations on 3 points: 2 end-blocks + central support

Flex features (made in Rui's workshop at CERN and QA at Genova):

- Mix of 4 Cu-layers and 2 Al-layers for the LV lines. Total thickness ${\sim}450 \mu m$
- The 2 Al-layers are processed with CVD for Chrome and Copper (vias)
- The wings supply through 1 layer the connectivity for every FE.
 Wing thickness 70µm
- Wings are folded and glued at 180° for very precise envelope required for the integration





Module Loading

The module loading and QA consisted of 12 working steps

Key features of the loading procedure:

- Modules are mounted with a thermal grease interface + epoxy glue drops
- Thermal grease was qualified for its good thermal performance and for its radiation hardness
- Rework and module replacement is possible but not straight forward → few additional damages observed after this operations
- 11 out of 20 staves were thermal cycled with loaded modules for QA Electrical tests and metrology survey were made before and after this operation \rightarrow 2 FE died after this operation (not explained)
- Electrical insulation between HV groups are finally inserted \rightarrow Thin polyimide layer in module gaps



Module Loading - Rework

Out of 20 production staves made 14 got 1 and up to 4 module replacements

- 54% is due to damage during one of the loading or rework step
- 21% are identified after corrosion rework at DSF
- 18% are linked to FE issues not identified at an early stage
- 7% are seen at the very last step of the QA

Level of exposure to damage risk is height \rightarrow To be investigated







Modules are thermally and mechanically bonded to a stave

- Thermal grease pad
- 2 glue drops per FE (size of 2mm

Removing a module is always destructive

Module Loading - Overview

- 273 DC Modules Received
 - 240 Modules Loaded on production staves
 - 23 used for reworking
- 103 CNM Modules Received
 - 88 Loaded on staves
 - 4 used for reworking
- 79 FBK Modules Received
 - 72 Loaded on staves





Almost 1 year of production for 20 staves
 → Considered as a big success with a lot of lessons learned

- Work parallelization could allow having 1 stave production rate per week
- Average time spent on a stave is 16 wd while it is 10 wd if there is no rework

p, Genova 2014

Stave Quality Assurance

Target: Final test and inspections which will define the acceptance for integration

Working steps:

- Visual inspection + high resolution pictures
- Power test and IV scans
- Basic digital and analog functionalities
- Tuning 1st at warm temperature
- Tuning at cold temperature at -15°C to -20°C
- 3 thermal cycles from warm to cold in operation
- Source scan Sr90 (for disconnected pixels)





Typical results from stave QA



IBL issues

History of big crisis:

- 1st one in September 2012: Bump bonding defects (short and open) after FC Resolved
- 2nd one in September 2013: Corrosion issue found accidentally after stave07 and 08 got frozen – Rework completed

ightarrow Both impacted the schedule by several months

Origin:

Issues met

- 1. Bump bonding defects: Likely to be due to the FC machine together with the tacking method for reflow. When both were changed the problem disappeared!
- 2. Corrosion issue: DI water tests allowed to observe an extreme sensitivity of wet flex surface which with the galvanic coupling and the presence halogen explained the chemical attack of the Al-wire.
 - White persistent residue AI(OH)3
 - Detected halogen in samples taken from production staves after corrosion spotted



Corrosion study

Understanding and questions:

- The corrosion can be reproduced even on bare cleaned flex with the drop of DI water
- Also seen on most of the flex producers while not systematically not on all pads
- The most aggressive cleaning seems to help but also weaken the gold metallization
- Coating the surface like with Urethan compounds show very good protection
- EDS/XPS/FBI analysis showed:
 - Halogen (Cl or F) associated with the corrosion product (residue)
 - No surface halogen contamination measured on cleaned samples
 - One over two techniques showed significant Fluorine into the gold layer (~7nm)

ightarrow Where the CI and F could come from? Surface migration, Coverlay, gold metallization?

| | Tspectrum 1 Stave08 | - Residue | Spectr | um 1 "Spectrum 2 "Spectrum 3 | Spectrum 4 | | | | | | | |
|-----|------------------------|-----------|------------------------|---------------------------------|------------|-----------------|-----------------|--------------------------------------|----------------------------------|--------------------------------------|--|--------|
| ent | Weight% | Atomic% | A Miller The | - 6- C- | | | | | A | 3 | | |
| L | | | 9.um | Electron Ims | Spect | | ^{2 μm} | EHT = 10. WD = 10.0 Signal A = | .00 kV Sa 0 mm Wi ⊧SE2 Sta | mple 10 rebond NTC A8-2 ave 08 | Mag = 1.8 Barbora BA Date :25 Se | ARTOVA |
| | 14.37 | 20.70 | Spectrum | | С | 0 | F | Al | Si | Р | S | Cl |
| | 53.17 | 57.48 | Spectrum 1 | | 6.2 | 2.3 | | 90.8 | 0.7 | | | |
| | 4 05 | 3 69 | Spectrum 2 | | 9.2 | 4.1 | | 86.0 | 0.8 | | | |
| | 26.01 | 17.25 | Spectrum 3 | | 16.0 | 34.6 | | 48.5 | 0.6 | | | 0.3 |
| | 20.91 | 17.25 | Spectrum 4 | | 17.3 | 47.7 | 1.1 | 32.0 | 0.4 | 0.8 | 0.4 | 0.4 |
| | 0.98 | 0.60 | Spectrum 5 | | 25.6 | 54.0 | 1.7 | 17.4 | 0.3 | 0.5 | 0.2 | 0.2 |
| | 0.51 | 0.28 | 9 th Trento | Workshop | , Genov | <i>v</i> a 2014 | | | | | | |

Elem

Sр1 С К О К

AI K

Si K

Issues met

Stave Rework

Corrosion issue: Right after the observed problem on 11 of the 12 produced staves a TF was set-up to investigate the cleaning, the understanding of the origin of the pollution, the stave rework and, the potential risk wrt the B-field and the LV current fluctuations

What is known:

- The origin of the pollution is on the flex (same issue on many manufacturers) but it is not clear where the Cl/F is located (metal layer/kapton)?
- No efficient cleaning works without degrading the metallization layer
- Potting was qualified on real module wrt to electrical functionalities before/after TC and Irradiations. → Not adopted change due to long term operation uncertainties
 Rework consists of: Cleaning after wire removal, and re-bonding all the FE and wing pads

Corroded wing region Before wire removal and cleaning

After wet cleaning

Cleaned in term of corrosion residue but not free of halogen



ftave prod.

Overview of the produced staves

Target is to get the best 14 staves out of the 20produced

| Stave # | Corroded and reworked? | roded and Passed worked? QA | | Stave # | Corroded and reworked? | Passed QA | # defective channels ‰ | |
|------------|------------------------|--------------------------------|------|------------|------------------------|--------------|---------------------------|--|
| 1 | Yes | Yes | 1.18 | 11 | No | Yes | 0.68 | |
| 2 | Yes | Yes | 0.67 | 12 | Yes | Yes | 0.63 | |
| 3 | Yes | Not yet | - | 13 | No | Yes | 0.83 | |
| 4 | Yes | Yes | 0.93 | 14 | No | Yes | 2.18 | |
| 5 | Yes | Yes | 0.70 | 15 | No | Yes | 1.00 | |
| 6 | Yes | Yes | 0.85 | 16 | No | Yes | 1.02 | |
| 7 | Yes | No | 1.08 | 17 | No | Yes | 1.22 | |
| 8 | Yes | Νο | 3.30 | 18 | No | Yes | 1.47 | |
| 9 | Yes | Yes | 1.29 | 19 | No | Yes | 1.13 | |
| 10 | Yes | Yes | 0.75 | 20 | No | Not yet | - | |

• Stave 7 and 8 were classified as failing after the condensation incident (used for practicing for the next integration steps)

• FE module criteria was based on ranking less than 1% defects per FE (including additional penalties identified during the production) but stave defects is at ‰ level

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IBL package

IBL Package overview

2 half shells (IPT connection to BP)





- All staves and services are packed inside 12mm envelope along 7m long structure
- The beam pipe is integrated inside IBL package and free to be extracted

Beam pipe extender (service wrapping)

IPT is integrated on the MPC (Multi **Purpose Container**)

Sealing and clamping rings

Service rings

Inner part of the sealing ring

Beam piep integration into the IPT structure





IPT

IBL Service end

& support at

PP1

IBL integration

Next step before integration is the cooling pipe extension for each stave to 7m long by brazing



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IBL service integration

Practice of service assembly and integration with all the strain relief along the IPT structure

- CTE mismatch of the copper type-1 bundles will be absorbed by the controlled waves
- Intermediate flex joining the stave to the Type-1 is corrugated and allows to compensate for small inaccuracy and CTE



Qualification of the stave and service integration thanks to the connectivity set-up

Features:

- Can test that all the FE functionalities is working
- No cooling required & test is performed in less than 5s
- Interlock is always active based on temperature survey
- Setup is mobile and can be also used in the pit
- Two set-ups built to work in // on the two sides







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Tests of staves on the IPT

After integration of stave07, 08 and service for practicing the two staves could be characterized with CO2 cooling and using the final hardware components including services.

- Operating conditions +15°C on the cooling line
- Very stable condition in term of cooling and operation
- Dryness of the volume was about 2-3% RH
- Readout system based on RCE
- DAQ with the production ROD/BOC was also tested successfully (limited tests)
- Efficient team for work preparation and tests







Tests

"Commissioning" on the IPT

Excellent results were obtained & compatible with QA results or slightly better



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"Commissioning" on the IPT – Con't

Surface commissioning happened with two staves with the full off-detector chain

All the tests performed were completed with success:

- Connectivity finally understood and corrected on many levels
- Excellent performance with noise performance and tuning level
- Low noise occupancies and no increased occupancy with synchronous external triggering at 5kHz of the two stave
- No increased noise occupancy on one stave/half-stave when threshold scans are running on the neighbor stave/half-stave
- Beautiful cosmic tracks along the entire FE
- Nice source data with Am241 and Sr90 source

Tests performed in Jan 14



Feedback - Noise on FBK modules

Higher noise on FBK modules are regularly observed:

- During Threshold scan → 1st four FEs on A-side are often FBK module
- Noise sensitivity seen when HitBus is enable and wire bond connected on the flex
- Noise sensitivity seen underneath the NTC when they are powered
- Double trigger noise tests exhibit some noise on FBK module into some BC ID

NB:

- It seems that the sensor backplane has a sensitive coupling to the module flex design features
- All of this should have only little impact during operation (Threshold can be adjusted, and HB is not used)



Feedback - Noise on FBK modules (Con't)





HitBus wire bonds:

- Connected on all modules between FE and flex
- Connected on reworked staves on wing side
- Register that can be disabled and not needed in operation





HitBus: FE feature that allows self-triggered operation mode This line is active when the chip have digital activities and the 'HitBus' register is enable

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Feedback - Noise on FBK modules (Con't)

- Observed noise spot which fit with the NTC location
- Measurement from UniGe with NTC power at 5V but also seen at CERN when supplying at 2.5V
- Modules are always FBK when NTC is powered. Not seen on planar and CNM modules





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Tests



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Tests

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IBL insertion tests on the mock-up

Extremely delicate part for the IBL installation is the insertion

A mock-up exists in bldg 180 to practice (originally to minimize the time of intervention in the cavern and review the procedures). Tests made first by insertion by hands \checkmark

- Successful insertion tries
- Second stage of test with linear motor and torque limit \checkmark
 - Repeat the above operations with services loaded into the sealing rings and test also the leak rate
 - Practice the Z positioning pin insertion (IPT wrt IST)
 - Practice the insertion with wrapped services at IPT extremities
 - Practice the service unwraping \rightarrow procedure

ID Mockup for installation tries



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CO₂ cooling system

IBL cooling features:

CO2 cooling

- CO2 cooling is new for ATLAS
- Cooling capacity is for 3kW
- Two cooling plants running in parallel
- → Increase the safety during bake-out in addition to the blow-off system
- Plant & 100m vacuum transfer lines already installed with distribution system close the detector
- Commissioning and 1st circulation of liquid CO2 started last week success fully
- Electrical break at the junction of the Ti and SS pipe was a technological challenge









| Work steps | Time line |
|---|--|
| Completion of the last staves which required module replacement | mid of February |
| Completion of stave rework | Beginning of February |
| Completion of stave QA | mid-end of February |
| Completion of readout of stave 07 & 08 around IPT | Beginning of February |
| IPT engineering work – Ti-extremity to IPT electrical connection + sealing ring installation | Mid of February |
| Start of brazing of the 1^{st} 3 staves and integration of the 1^{st} stave | Mid of February (started) |
| Completion of stave and service integration (including functional electrical tests) | Mid of April |
| Completion of service wrapping and IBL packing for pit | End of April |
| IBL transport to cavern and installation /alignment inside the Pixel | From May 5 th to 14 th |
| Electrical and cooling service connection and final tests | Mid May to end of June |

Conclusions

IBL is a detector with many interesting challenges such as:

- > New detector technology: 1st time 3D detector produced for a detector
- > Thinner sensor and FE: impact on the flip-chipping
- > New FE in 130nm: after FEI4A, the B version is working as expected with set of improvement
- Stave AI-Cu flex to save material budget: 1st time ever tried this technology
- > Light stave structure: Light, long and stiff object including the thin Ti-pipe
- > Stave extension to 7m long for cooling: Brazing technique required a lot of investigations
- > Integration with tight clearances: thanks to very precise and very well engineered tools
- > Overall engineering structures with new composite material
- **Two major crisis** allowed to gain more experience about what we are building but also good to remind us that building even a small scale Pixel detector is not a straight forward project

The integration and commissioning tests results are extremely positive → Allowing to complete the IBL with a higher level of confidence

1st stave integrated last week











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Backup Quality and yield of received wafers (depletion voltage) latest numbers we received measurement results performed at CiS these include IV measurements and depletion voltage distribution of 150 depletion voltages Depletion voltage 46±6 V mpv on, batch 1-9, depletion voltage, CIS measurements, accepted wafers IBL produc Entries voltage distribution Entries Mean RMS CiS measurements of some wafers 25 show higher values 20 15 still to be re-checked with independent measurements 10 5 Expect to see lower values

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-70

-60

-50

-40

-30

-20

-10 voltage [V]

150

-50.49

10.04



SC-CNM yields smoothed





SC-FBK yields smoothed





DC yields smoothed



Feedback - Noise on FBK modules – Con't



Stave Score

| Stave | #BadPix | BadPix Ratio (‰) | ▼ Score | Better score | |
|-------|---------|------------------|---------|--------------|--|
| ST02 | 579 | 0.67 | 0.44 | | |
| ST13 | 718 | 0.83 | 0.56 | | |
| ST11 | 585 | 0.68 | 0.58 | | |
| ST12 | 542 | 0.63 | 0.62 | | |
| ST10 | 646 | 0.75 | 0.62 | | |
| ST05 | 601 | 0.70 | 0.68 | | |
| ST04 | 799 | 0.93 | 0.69 | | |
| ST06 | 734 | 0.85 | 0.79 | | |
| ST16 | 879 | 1.02 | 0.83 | | |
| ST15 | 864 | 1.00 | 0.84 | | |
| ST18 | 1266 | 1.47 | 0.94 | | |
| ST09 | 1110 | 1.29 | 1.00 | | |
| ST17 | 1052 | 1.22 | 1.01 | | |
| ST01 | 1011 | 1.18 | 1.04 | | |
| ST14 | 1877 | 2.18 | 1.11 | Worse score | |

score
$$\equiv \left(\frac{\sum_{i \in \text{BadPixel}} w_i}{\sum_{i \in \text{AuD}; \text{xel}} w_i}\right) \times 10^3$$

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Mapping algorithm – Two points correlation function

It is commonly used in cosmology to describe distribution of observables in the sky using two-point correlation function for studying the structure of the space.

$$P(r) = \int d^3x \int d^3x' \underbrace{A(x)}_{A(x)} A(x') \delta^3(|x - x'| - r)$$

We don't like IBL stave bad pixels localized to some area which creates holes, therefore bad pixels are better to be distributed as uniform as possible.



The basic concept: Compare the correlation function with uniform distribution ("baseline"), and the deviation of the data from the baseline can be a measure of anisotropy.





Layout summary table – Stave integration order

| Stave | DSF Rework | #Bad | Score | Plan- arity | Мар | BadPix Distribution | | | | |
|-------|---------------|------|-------|----------------|----------------|--|--|--|--|--|
| ST01 | YES | 1011 | 1.04 | 224 | | 11 12 2 2 2 2 2 2 2 2 2 2 2 2 2 2 2 2 2 | | | | |
| ST02 | YES | 579 | 0.44 | 205 | #2 | 이 눈 이 있는 것 같은 것 같 | | | | |
| ST04 | YES | 799 | 0.69 | 235 | | | | | | |
| ST05 | YES | 601 | 0.68 | 189 | #14 | | | | | |
| ST06 | YES | 734 | 0.79 | 290 | #12 | | | | | |
| ST09 | YES | 1110 | 1.00 | 229 | | | | | | |
| ST10 | NO | 646 | 0.62 | 243 | | 방지원했음작, 이거리 범인이었음식은 엄청한 물관에서 지지않았다. | | | | |
| ST11 | NO | 585 | 0.58 | 298 | | | | | | |
| ST12 | YES | 542 | 0.62 | 314 | | | | | | |
| ST13 | NO | 718 | 0.56 | 224 | | | | | | |
| ST14 | NO | 1877 | 1.11 | 218 | | : : : : : : : : : : : : : : : : : : : | | | | |
| ST15 | NO | 864 | 0.84 | 325 | #13 | , 2017년 2017년 2017년 1월 2017년 1월 2017년 2017 | | | | |
| ST16 | NO | 879 | 0.83 | 329 | | | | | | |
| ST17 | NO | 1052 | 1.01 | 114 | #1 | | | | | |
| ST18 | NO | 1266 | 0.94 | 336 | | | | | | |
| | | | | (| +η ◀ Aside) | +3 +2.5 +2 +1 0 -1 -2 -2.5 -3 (Cside | | | | |
| | | | | | | Weight on each nivel by stall accentance | | | | |
| | | | | | | weight on each pixel by eta-acceptance $1 \qquad 1$ | | | | |
| | | | | | | $w_i = \frac{1}{\cosh(\eta)} = \frac{1}{\cosh(\sinh(z/r_0))}$ | | | | |
| | | | | | | $(z = r_0 \sinh(\eta))$ | | | | |